

# INFORMATION DISCLOSURE CITATION

(Use several sheets if necessary)

Local Number (Optional)

S11

Application Number

10/061,458

10/061,458

Applicant(s)

Greenberg, et al.

Filing Date

10/26/01

Group Art Unit

1615  
unknown

## U.S. PATENT DOCUMENTS

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
CA		4,991,582	2/12/91	Byers, et al.			
		5,750,926	5/12/98	Schulman, et al.			
		5,797,898	8/25/98	Santini, Jr. et al.			
		6,123,861	9/26/00	Santini, Jr. et al.			

## FOREIGN PATENT DOCUMENTS

REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						YES	NO

## OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

CA	D.M. Zhou, et al., "Accelerated Corrosion Tests on Silicon Wafer for Implantable Medical Devices", Proc. of 198th Electrochemical Society Meeting, 363, October 2000
AA	D.M. Gruen, "Nanocrystalline Diamond Films" Annu. Rev. Mater. Sci., 29 211-59 (1999)
EXAMINER	DATE CONSIDERED
	4/25/05

EXAMINER: Initial if citation considered; whether or not citation is in conformance with MPEP Section 609: Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

# INFORMATION DISCLOSURE CITATION

(Use several sheets if necessary.)

Docket Number (Optional)

S11

Applicant Number

10/635,633  
#046458

Applicant(s)

Greenberg, et al.

Filing Date

10/26/2001

Group Art Unit

1615  
unknown

EXAMINER  
INITIAL

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

D.M. Gruen, et al. "Buckyball Microwave Plasmas: Fragmentation and Diamond Film Growth", J. Appl. Phys., 75 (3) 1758-63 (1994)

EXAMINER

DATE CONSIDERED

\*EXAMINER: Initial if citation considered. Whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.